



AUG 12 2002

BOX AF
RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINER GROUP 2851

03560.002558.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yuji SUDOH et al.

Application No.: 09/532,022

Filed: March 21, 2000

For: EXPOSURE APPARATUS AND A
DEVICE MANUFACTURING METHOD
WHICH KEEP TEMPERATURE OF A
DIAPHRAGM OF A PROJECTION
OPTICAL SYSTEM SUBSTANTIALLY
CONSTANT

) Examiner: H. Nguyen

) Group Art Unit: 2851

) August 12, 2002

*Please
Do not
enter
8/22/02
HN*
The Commissioner for Patents
Box AF
Washington, D.C. 20231

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TECHNOLOGY CENTER 2800

AMENDMENT AFTER FINAL REJECTION
WITH PETITION FOR EXTENSION OF TIME

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the

Office Action dated March 12, 2002, for two months from June 12, 2002, to August 12, 2002. A